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UNITED STATES PATENT AND TRADEMARK OFFICE
PATENT TRANSMITTAL FORM

Applicant(s): DINGER et al.

Serial No.: 10/779,516

Filed: February 13, 2004

For: SUBSTRATE MATERIAL FOR X-RAY OPTICAL COMPONENTS

Art Unit: 2878

Examiner: Not Yet Assigned

Confirmation No.: 8909

Customer No.: 27623 Attorney Docket No.: 637.0033USX

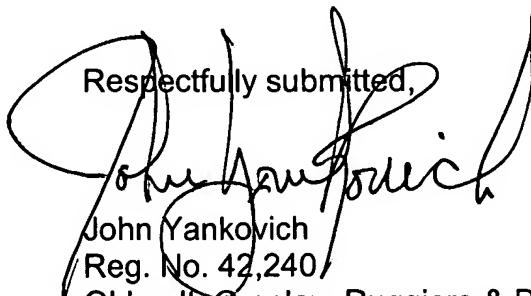
Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

We are enclosing:

1. Supplemental Information Disclosure Statement with copies of references;
2. PTO Form 1449;
3. Transmittal letter in duplicate; and
4. Postcard.

Please charge any additional fees or credit any such fees, if necessary to Deposit Account No. 01-0467 in the name of Ohlandt, Greeley, Ruggiero & Perle. A duplicate copy of this sheet is attached.

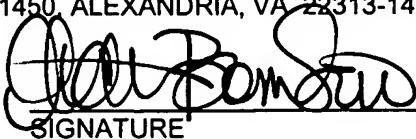
Respectfully submitted,

John Yankovich
Reg. No. 42,240

Ohlandt, Greeley, Ruggiero & Perle, L.L.P.
One Landmark Square, 10th Floor
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(203) 327-4500

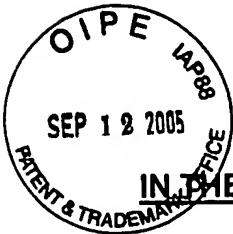
CERTIFICATE OF MAILING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING DEPOSITED WITH THE U.S. POSTAL SERVICE AS FIRST CLASS MAIL IN AN ENVELOPE ADDRESSED TO: MAIL STOP AMENDMENT, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450, ON September 9, 2005.

Michelle M Bombino
NAME


SIGNATURE

9/9/05
DATE



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with applicants' duty of disclosure under 37 C.F.R. §1.56, we are enclosing form PTO-1449 listing information that may be material to the patentability of this application.

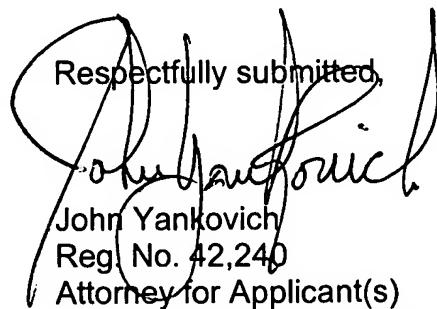
37 C.F.R. 1.98 does not require a copy of U.S. patents or published U.S. patent applications to be included with an information disclosure statement. Accordingly, Applicant is not including a copy of any U.S. patent or published U.S. patent application.

We are also enclosing copies of the non-US references listed on the attached PTO-1449.

It should be understood that attention has been called to the citations that have been deemed to be pertinent to the claimed present invention. In concluding what was pertinent, the criteria employed was considered most appropriate in light of the invention shown in the present application. However, the Examiner or others may deem some other criteria to be just as appropriate or more appropriate. Therefore, the Examiner is respectfully urged to review the listed citations and to make the usual careful independent search for other prior art that may be pertinent.

Since this Information Disclosure Statement is being filed prior to the issuance of the first Office Action based on the merits, no petition or fee is required.

Applicant respectfully requests favorable consideration and that this application be passed to allowance.

Respectfully submitted,

John Yankovich
Reg. No. 42,240

Attorney for Applicant(s)
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CUSTOMER NO.: 27623



Sheet 1 of 1.

FORM PTO-1449		Docket Number (Optional) 637.0033USX	Application Number 10/779,516
INFORMATION DISCLOSURE CITATION IN AN APPLICATION <small>FOR TRADEMARKS</small>		Applicant DINGER et al.	
(Use several sheets if necessary)		Filing Date February 13, 2004	Group Art Unit 2878

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	WO02099818	12/12/02	WIPO			XXX	

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

	Allen et al. "An Ion Figuring System for Large Optic Fabrication", SPIE Vol. 1168 Current Developments in Optical Engineering and Commercial Optics (1989), pp. 33-50.
	Allen et al. "Demonstration of an Ion Figuring Process", SPIE Vol. 1333 Advanced Optical Manufacturing and Testing (1990), pp. 22-33
	Wilson et al. "Surface Figuring Using Neutral Ion Beams", SPIE Vol. 966 Advances in Fabrication and Metrology for Optics and Large Optics (1988), pp. 74-80.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.